

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Atty Docket No. IL-10625		Serial No.			
INFORMATION DISCLOSURE STATEMENT STATEMENT BY APPLICANT		Applicant Kirk P. Seward et al					
(use several sheets if necessary)		Filing Date		Group			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
JK		5,405,337	4/95	R.S. Maynard	604	281	
JK		5,944,701	8/99	W.R. Dubrul	604	264	
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation YES NO
JK		JP9123330	Abstr.	Japan			
JK		JP9109320	Abstr.	Japan			
JK		JP8199080	Abstr.	Japan			
JK		JP7290571	Abstr.	Japan			
JK		JP3059142	Abstr.	Japan			
JK		JP3023379	Abstr.	Japan			
OTHER DISCLOSURES (including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)							
JK		1.	H. Tobushi et al, Journal of Intelligent Materials Systems and Structure, Vol 8, Aug. 1007, pp. 711-718.				
JK		2.	G. Bourbon et al, SPIE-Int. Soc. Opt. Eng. 1998, pp. 147-158				
JK		3.	H. Tobushi et al, JSME International Journal, Series 1, Vol. 35, No. 3, 1992				
JK		4.	P. Krulevitch, Journal of Microelectromechanical Systems, Vol. 5, No. 4, Dec. 1996, pp. 270-282.				
Examiner	Jonefme			7/11/02			
Examiner: initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							